

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Granik et al.

Application No. 09/898,431

Filed: July 2, 2001

Confirmation No. 1914

For: METHOD OF COMPENSATING FOR
ETCH EFFECTS IN
PHOTOLITHOGRAPHIC PROCESSING

**FILED VIA EFS
ON OCTOBER 25, 2007**

Examiner: Thomas H. Stevens

Art Unit: 2121

Attorney Reference No. 1011-78093-02

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UNITED STATES PATENT AND TRADEMARK OFFICE

**REQUEST FOR CONTINUED EXAMINATION
TRANSMITTAL LETTER**

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the application referenced above.

Submission required under 37 C.F.R. § 1.114

- ☒ Enclosed
☒ Amendment and Request for Reconsideration

FILING FEE					
For	No. after amendment	No. paid for previously	Present Extra	Rate	Fee
Fee under 37 CFR 1.17(e)					\$810.00
Total Claims	24	- 25	= 0	\$50.00	\$ 0.00
Indep. Claims	6	- 7*	= 0	\$210.00	\$ 0.00
TOTAL FILING FEE					\$810.00

* greater of twenty or number for which fee has been paid.

** greater of three or number for which fee has been paid.

☒ Charge \$810.00 to Deposit Account No. 02-4550.

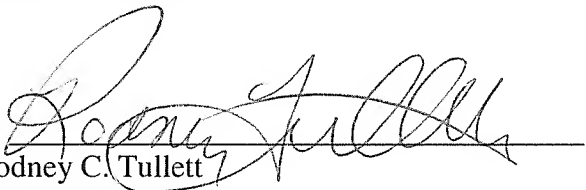
- ☒ Please charge any additional fees that may be required in connection with filing this RCE, or credit any overpayment, to Deposit Account No. 02-4550.

Respectfully submitted,

KLARQUIST SPARKMAN, LLP

One World Trade Center, Suite 1600
121 S.W. Salmon Street
Portland, Oregon 97204
Telephone: (503) 595-5300
Facsimile: (503) 595-5301

By


Rodney C. Tullett
Registration No. 34,034

cc: Docketing